



A handwritten signature in black ink, appearing to read "JRW".

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**  
Takashi OHSAKO et al. : Attorney Docket No. 2003\_1364A  
Serial No. 10/677,221 : Group Art Unit 2823  
Filed October 3, 2003 : Examiner Joannie Garcia

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated May 17, 2006, please amend the above-identified application as follows.